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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO	
10/707,426	12/12/2003	Rainer klaus Krause	DE920020037	1425	
	7590 12/14/2004		EXAMINER		
INTERNATIONAL BUSINESS MACHINES CORPORATION DEPT. 18G			MCPHERSON, JOHN A		
BLDG. 300-482			ART UNIT	PAPER NUMBER	
2070 ROUTE 52 HOPEWELL JUNCTION, NY 12533			1756		
	,		DATE MAIL ED: 12/14/2004		

Please find below and/or attached an Office communication concerning this application or proceeding.

<u> </u>		Application No.	Applicant(s)	
		10/707,426	KRAUSE ET AL.	
Office Action Summary		Examiner	Art Unit	
		John A. McPherson	1756	
Period fe	The MAILING DATE of this communication ap	pears on the cover sheet w	ith the correspondence addr	ess
A SH THE - Exte after - If the - If NC - Failu Any	IORTENED STATUTORY PERIOD FOR REPL MAILING DATE OF THIS COMMUNICATION. In SIX (6) MONTHS from the mailing date of this communication. If period for reply specified above is less than thirty (30) days, a reput period for reply is specified above, the maximum statutory period ure to reply within the set or extended period for reply will, by statutor reply received by the Office later than three months after the mailing led patent term adjustment. See 37 CFR 1.704(b).	136(a). In no event, however, may a in the statutory minimum of thir will apply and will expire SIX (6) MON and a cause the application to become AB	reply be timely filed  ty (30) days will be considered timely.  ITHS from the mailing date of this com  BANDONED (35 U.S.C. 8 133)	munication.
Status				
1)⊠ 2a)□ 3)□	Responsive to communication(s) filed on 12 E.  This action is <b>FINAL</b> . 2b) This Since this application is in condition for alloward closed in accordance with the practice under E.	s action is non-final. Ince except for formal matt	ers, prosecution as to the n	nerits is
Disposit	ion of Claims			
4)⊠ 5)□ 6)⊠ 7)□ 8)□	Claim(s) <u>1-8</u> is/are pending in the application.  4a) Of the above claim(s) is/are withdra  Claim(s) is/are allowed.  Claim(s) <u>1-8</u> is/are rejected.  Claim(s) is/are objected to.  Claim(s) are subject to restriction and/or			
Applicat	ion Papers			
10)⊠	The specification is objected to by the Examine The drawing(s) filed on <u>12 December 2003</u> is/a Applicant may not request that any objection to the Replacement drawing sheet(s) including the correct The oath or declaration is objected to by the Ex	are: a)⊠ accepted or b)□ drawing(s) be held in abeyar tion is required if the drawing	nce. See 37 CFR 1.85(a). (s) is objected to. See 37 CFR	1.121(d).
Priority ι	under 35 U.S.C. § 119			
a)l	Acknowledgment is made of a claim for foreign All b) Some * c) None of:  1. Certified copies of the priority document 2. Certified copies of the priority document 3. Copies of the certified copies of the priority application from the International Bureau See the attached detailed Office action for a list	s have been received. s have been received in A nty documents have been u (PCT Rule 17.2(a)).	pplication No received in this National St	age
Attachmen	t(s)			
2) 🔲 Notic 3) 🔯 Inforr	te of References Cited (PTO-892) te of Draftsperson's Patent Drawing Review (PTO-948) mation Disclosure Statement(s) (PTO-1449 or PTO/SB/08) or No(s)/Mail Date 12/12/03.	Paper No(s	ummary (PTO-413) )/Mail Date iformal Patent Application (PTO-1) 	52)

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#### **DETAILED ACTION**

## Specification

1. The disclosure is objected to because of the following informalities: it appears that in paragraph [0027] the text "Anna Marie Petrera/Markham/IBM @ IBMCA" should be deleted. Appropriate correction is required.

### Claim Rejections - 35 USC § 102

2. The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

- (b) the invention was patented or described in a printed publication in this or a foreign country or in public use or on sale in this country, more than one year prior to the date of application for patent in the United States.
- (e) the invention was described in (1) an application for patent, published under section 122(b), by another filed in the United States before the invention by the applicant for patent or (2) a patent granted on an application for patent by another filed in the United States before the invention by the applicant for patent, except that an international application filed under the treaty defined in section 351(a) shall have the effects for purposes of this subsection of an application filed in the United States only if the international application designated the United States and was published under Article 21(2) of such treaty in the English language.

Claims 1-2 and 4-7 are rejected under 35 U.S.C. 102(e) as being anticipated by US 6,653,030 to Mei et al. (Mei). Mei discloses a method for fabricating micron and sub-micron sized features within a polymer layer that combines mechanical stamping with lithography-like UV radiation-induced polymer curing, wherein small features are directly imprinted with an optical-mechanical stamp, and large features are created by exposing the polymer through the optical-mechanical stamp. The optical-mechanical stamp is manufactured by molding polydimethyl siloxane (PDMS) and fixing a UV mask

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to the stamp. See the abstract; column 6, line 16 to column 7, line 4; column 8, lines 15-25; and Figures 4A-D.

### Claim Rejections - 35 USC § 103

- 3. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:
  - (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

Claims 1-8 are rejected under 35 U.S.C. 103(a) as being unpatentable over US 6,653,030 to Mei et al. (Mei) in view of US 5,901,432 to Armstrong et al. (Armstrong). The disclosure of Mei is discussed above in paragraph 2. Additionally, Mei teaches utilizing the optical-mechanical stamping process to form electro-magnetic devices. See column 1, lines 20-25. However, Mei does not disclose a method wherein the mask comprises a plating pattern, or wherein the device produced is a P2 structure of a magnetic recording head. Armstrong discloses a method for making a thin film inductive write head comprising the steps of forming photoresist pattern to define the shape of a second pole piece (P2), and then electroplating to form the second pole piece. See the abstract; column 5, line 35 to column 6, line 5; and Figures 3E-3J. It would have been obvious to one skilled in the requisite art of form a plating pattern by photolithography when manufacturing a second pole piece, as taught by Armstrong. utilizing the optical-mechanical stamping process of Mei because it is taught that photo exposing plating patterns in photoresist provides a pattern for the plating of a P2 pole piece of a magnetic head, and it is taught that the optical-mechanical stamping process

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patterns features within a photoresist layer in device manufacturing processes, including processes of forming electro-magnetic devices.

### Claim Rejections - 35 USC § 102/103

4. Claim 8 is rejected under 35 U.S.C. 102(b) as anticipated by or, in the alternative, under 35 U.S.C. 103(a) as obvious over US 5,901,432 to Armstrong (Armstrong).

Armstrong discloses a magnetic write head comprising a second pole piece (P2). See the abstract; column 5, line 35 to column 6, line 5; and Figures 3E-3J. The P2 pole piece of the prior art is formed by plating into a photoresist pattern, as is the P2 structure of the present invention, although the photoresist of the prior art is not patterned by the process of the present invention. Both P2 structures are formed of plated metal, therefore the design of the mask utilized to form the photoresist pattern does not appear to provide a patentable distinction between the claimed P2 structure and the P2 pole piece of the prior art, when the resulting structures are the same.

It has been held that the patentability of a product does not depend on its method of production. If the product in a product-by-process claim is the same as or obvious from a product of the prior art, the claim is unpatentable even if though the prior art product was made by a different process. *In re Thorpe*,777 F.2d 695, 698, 227 USPQ 964, 966 (Fed. Cir. 1985). Furthermore, when the prior art discloses a product which reasonably appears to be either identical with or only slightly different than a product claimed in a product-by-process claim, a rejection based alternatively on either section

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102 or section 103 of the statue is eminently fair and acceptable. *In re Brown,* 459 F.2d 531, 535, 173 USPQ 685, 688 (CCPA 1972). See MPEP 2113.

5. Any inquiry concerning this communication or earlier communications from the examiner should be directed to John A. McPherson whose telephone number is (571) 272-1386. The examiner can normally be reached on Monday through Friday, 8:00 AM to 4:30 PM.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Mark Huff can be reached on (571) 272-1385. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

John A. McPherson Primary Examiner Art Unit 1756

JAM 12/10/04